

03/11/2008

Docket No. 1514.1032

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
EXPEDITED PROCEDURE PURSUANT
TO 37 CFR §1.116 REQUESTED
Attn: Mail Stop AF

In re the Application of:

Ji Yong PARK et al.

Application No. 10/690,507

Group Art Unit: 1792

Confirmation No. 6043

Filed: October 23, 2003

Examiner: Matthew J. Song

For: METHOD FOR MANUFACTURING POLYCRYSTALLINE SILICON THIN FILM AND
THIN FILM TRANSISTOR FABRICATED USING POLYCRYSTALLINE SILICON THIN
FILM MANUFACTURED BY THE MANUFACTURING METHOD

RESPONSE AFTER FINAL REJECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 26, 2008

Attention: **BOX AF**

Sir:

This is in response to the in-person Office Interview scheduled and conducted at 1pm on Tuesday February 26, 2008 and the outstanding Office Action mailed November 26, 2007, and having a period for response set to expire on February 26, 2008.

Reconsideration of the claims is respectfully requested. The following remarks are respectfully submitted.